



ZFW

Docket No.: 050432-0645

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Douglas J. BONSER, et al.	:	Confirmation Number: 5274
Application No.: 10/791,759	:	Group Art Unit: 2818
Filed: March 04, 2004	:	Examiner: Tran, Long K.
For: METHOD OF REDUCING STI DIVOT FORMATION DURING SEMICONDUCTOR DEVICE FABRICATION		

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action
dated October 14, 2005.